IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

mendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Re:

Inventor(s):

Michael R. Rice, Martin R. Elliott, Robert B. Lowrance, Jeffrey C. Hudgens and Eric A. Englhardt

Title:

OVERHEAD TRANSFER FLANGE AND SUPPORT FOR SUSPENDING A SUBSTRATE CARRIER

Serial No .:

10/764,820

Filed: Examiner: January 26, 2004 Greenhut, Charles N.

Group Art Unit: 3652

Transmitted herewith is:

PTO Form 1449; <u>X</u>

Information Disclosure Statement with six cited references; and

X Return Postcard.

FEE CALCULATION									
c Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total				
Total Claims	N/A	- 20 =	-0-	X \$50.00	\$0.00				
Independent Claims	N/A	- 3 = -0-		X \$200.00	\$0.00				
Basic Filing Fee (\$300.00), Utility Search Fee (\$500.00), Utility Examination Fee (\$200.00) \$1000.00									
TOTAL FEES									

- XXThe Commissioner is hereby authorized to charge \$180.00 to Deposit Account No. 04-1696.
- XXThe Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 04-1696. A duplicate copy of this transmittal is enclosed.

XXPlease address all future correspondence to: **Customer # 41161** Dugan & Dugan, PC 55 South Broadway Tarrytown, NY 10591

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Express Mail Receipt No. EV605114859US

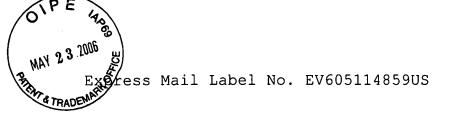
Date of Deposit:

Respectfully submitted,

Brian M. Dugan

Registration No. 41,720

(914) 332-9081



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Michael R. Rice et al.

Serial No. : 10/764,820

Filed: January 26, 2004

FOR : OVERHEAD TRANSFER FLANGE AND SUPPORT FOR

SUSPENDING A SUBSTRATE CARRIER

Group Art Unit: 3652

Customer No. : 41161

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§ 1.56 and 1.97, applicants wish to call the attention of the Examiner to the following references:

Foreign Art Reference No. EP 0663686 B1 (EPO)

Foreign Art Reference No. EP 0795892 A1 (EPO)

Weiss, Mitchell, "Evaluating 300-mm Fab Automation Technology Options and Selection Criteria", June 1997, MICRO, Vol. 15, No. 6, pages 65-66, 68, 70, 72, 74, 76, 78-79.

No-Author, "Equipe Helps Streamline 300 mm Wafer Processing", Dec. 1, 1997, Manufacturing Automation, Vol. 7, No. 3, page 1-5.

No-Author, "PRI Selected By Varian Semiconductor to Supply 300mm Integrated Front-End Buffering Solutions", Feb. 10, 2000, Newswire, Page 7434.

No-Author, "300mm Single-Wafer Handling" (Brief Article), Apr. 1, 2000, Solid State Technology, Vol. 43, No. 4, page 99.

Please charge deposit account No. 04-1696 in the amount of \$180.00 for consideration of this information disclosure statement under 37 C.F.R. \S 1.97(c)(2).

These references are also listed on the accompanying Information Disclosure Statement (Form PTO-1449).

Consideration of the foregoing in relation to this patent application is respectfully requested.

Respectfully Submitted,

Brian M. Dugan, Esq Registration No. 41,720

Dugan & Dugan, PC

Attorneys for Applicants

(914)332-9081

Dated:

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Tarrytown, New York

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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.												

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